

REMARKS

Claims 1-22 are pending in this application. By this Amendment, claims 1-3, 5 and 9 are amended. No new matter is added.

The courtesies extended to Applicant's representative by Examiner Parker at the interview held on September 9, are appreciated. The reasons presented at the interview as warranting favorable action are incorporated into the remarks below and constitute Applicant's record of the interview.

I. The Claims Define Patentable Subject Matter

The Office Action rejects claims 1, 10, 14 and 22 under 35 U.S.C. §102(b) as anticipated by U.S. Patent No. 6,141,066 to Matsushima. This rejection is respectfully traversed.

As agreed to during the interview, Matsushima fails to describe, teach or suggest an upper conductive layer disposed between a layer of said intermediate conductive layer and said layer of said pixel electrode; and a first contact hole formed in an area under said upper conductive layer, said first contact hole electrically connecting said drain region of said semiconductor layer of said thin film transistor to said intermediate conductive layer, as recited in claims 1, 10 and 14.

Applicant respectfully submits that claim 22 was improperly rejected because the Office Action fails to point out with particularity where in Matsushima the features of claim 22 may be found. However, the features of claim 22 were discussed during the interview, and Applicant respectfully submits that Matsushima fails to disclose, teach or suggest a light shielding film formed of a film forming said intermediate conductive layer; and a contact hole via which said capacitance line and said light shielding film are electrically connected with each other in an area under said data line, as recited in claim 22.

II. Conclusion

In view of the foregoing, it is respectfully submitted that this application is in condition for allowance. Favorable reconsideration and prompt allowance of claims 1-22 are earnestly solicited.

Should the Examiner believe that anything further would be desirable in order to place this application in even better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,



James A. Oliff

Registration No. 27,075

Jon F. Hadidi

Registration No. 46,427

JAO:JFH/al

Date: September 17, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--